

Low Pressure Digital Sensor

SM7335-BBE-S-002-000 Differential Pressure Sensor

FEATURES

- Pressure range from -2 to 2 inH₂O; differential output
- 2.5%FS accuracy
- 16-bit digital, pressure calibrated and temperature compensated output
- I²C Digital Interface
- Compensated temperature range: 0 to 65°C
- Robust JEDEC SOIC-16 package for automated assembly
- Manufactured according to ISO9001 and ISO/TS 16949 standards

DESCRIPTION

The SM7335 is a digital, ultra-low pressure MEMS sensor offering state-of-the-art pressure transducer technology and CMOS mixed signal processing technology to produce a digital, fully conditioned, multi-order pressure and temperature compensated sensor in JEDEC standard SOIC-16 package with a dual horizontal porting option. It is available in a differential pressure configuration.

Combining the pressure sensor with a signal-conditioning ASIC in a single package simplifies the use of advanced silicon micro-machined pressure sensors. The pressure sensor can be mounted directly on a standard printed circuit board and a high level, calibrated pressure signal can be acquired from the digital interface. This eliminates the need for additional circuitry, such as a compensation network or microcontroller containing a custom correction algorithm.

The SM7335 is shipped in sticks or tape & reel.

Medical	Industrial		
Sleep Apnea	Airflow Measurement		
СРАР	Pneumatic Gauges		
Ventilators	Pressure Switches		
Gas Flow Instrumentation	Safety Cabinets		
Air Flow Monitors	Life Sciences		
	Gas Flow Instrumentation		
	HVAC		

Silicon Microstructures, Inc. 2001-2018. All rights reserved



Absolute Maximum Ratings

All parameters are specified at Vdd = 3.3 V supply voltage at 25°C, unless otherwise noted.

No.	Characteristic	Symbol	Minimum	Typical	Maximum	Units
1	Supply Voltage	V _{DD}	3.0		5.5	V
2	Supply Current	I _{VDD}		3.2		mA
3	Compensated Temperature	T _{COMP}	0		+65	°C
4	Operating Temperature ^(a)	T _{OP}	0		+65	°C
5	Storage Temperature ^(a)	T _{STG}	-40		+125	°C
6	Proof Pressure ^(a, c)	P _{Proof}			+/-1.5	PSI
7	Burst Pressure ^(a, d)	P _{Burst}			+/-3.0	PSI

Notes:

a. Tested on a sample basis.

b. Clean, dry gas compatible with wetted materials. Wetted materials include silicon, epoxy, RTV, gold and aluminum.

c. Proof pressure is defined as the maximum pressure to which the device can be taken and still perform within specifications after returning to the operating pressure range

d. Burst pressure is the pressure at which the device suffers catastrophic failure resulting in pressure loss through the device.

Silicon Microstructures, Inc. 2001-2018. All rights reserved



OPERATING CHARACTERISTICS TABLE

All parameters are specified at Vdd = 3.3 V DC supply voltage at 25°C, unless otherwise noted.

No.	Characteristic	Symbol	Minimum	Typical	Maximum	Units
9	Supply Voltage	V _{DD}	3.0	3.3	3.6	v
10	Supply Current	I _{VDD}		3		mA
11	Digital Pressure Output [@] P_{MIN} (-2 inH ₂ O)	OUT _{MIN}		-26,214		Counts
12	Digital Pressure Output [@] P _{MAX} (2 inH ₂ O)	OUT _{MAX}		+26,214		Counts
13	Digital Full Scale Span	FS		52,428		Counts
14	Resolution (Digital Output)			16		Bits
15	Update Rate			2000		S/sec
16	Bandwidth	BW		125		Hz
17	Digital Output Accuracy ^(e)	ACC	-2.5		+2.5	%FS

Notes:

e. The accuracy specification applies over all operating conditions. This specification includes the combination of linearity, repeatability, and hysteresis errors over pressure, temperature, and voltage.

Qualification Standards

REACH Compliant ROHS Compliant PFOS/PFOA Compliant For qualification specifications, please contact Sales at sales@si-micro.com







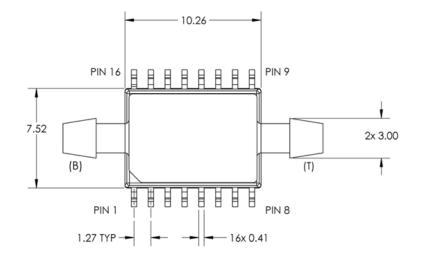


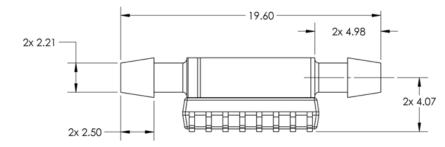


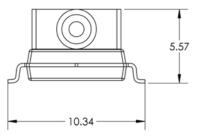


www.si-micro.com

SOIC-16 Dual Horizontal Package Dimensions





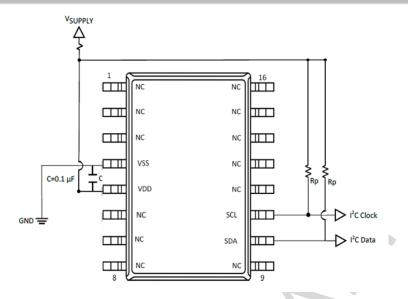


Notes:

- All dimensions in units of [mm]
- Moisture Sensitivity Level (MSL): Level 3
- Wetted materials: Silicon, glass, copper, silicone, epoxy, mold compound.
- Tolerance on all dimensions ±0.13 mm unless otherwise specified.
- [B] is tube connected to bottom side of sensor die.
- [T] is tube connected to top side of sensor die. Topside pressure is positive pressure. An increase in topside pressure will result in an increase in sensor output



SM7335 Applications Circuit



NOTES:

- The bypass capacitor C should be placed in close proximity to the device.
- The pull-up resistors R_p can for example be 4.7 k $\Omega.$

Package Labeling				
Pin No.				
1	NC (No Connect)			
2	NC			
3	NC			
4	VSS			
5	VDD			
6	NC			
7	NC			
8	NC			
9	NC			
10	SDA			
11	SCL			
12	NC			
13	13 NC			
14	NC			
15	NC			
16	NC			

NOTES:

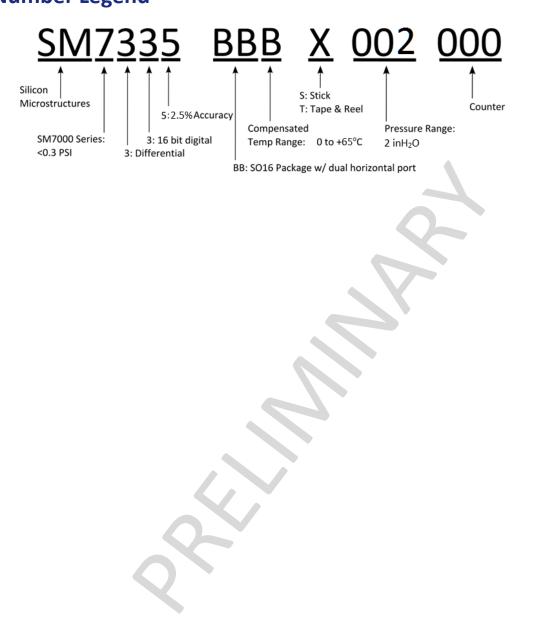
• Do not connect to NC pins

Silicon Microstructures, Inc. 2001-2018. All rights reserved

+1-(408) 577-0100 / sales@si-micro.com / www.si-micro.com



Part Number Legend



SM7335-BBE-S-002-000



Silicon Microstructures Warranty and Disclaimer:

Silicon Microstructures, Inc. reserves the right to make changes without further notice to any products herein and to amend the contents of this data sheet at any time and at its sole discretion.

Information in this document is provided solely to enable software and system implementers to use Silicon Microstructures, Inc. products and/or services. No express or implied copyright licenses are granted hereunder to design or fabricate any silicon-based microstructures based on the information in this document.

Silicon Microstructures, Inc. makes no warranty, representation, or guarantee regarding the suitability of its products for any particular purpose, nor does Silicon Microstructures, Inc. assume any liability arising out of the application or use of any product or silicon-based microstructure, and specifically disclaims any and all liability, including without limitation consequential or incidental damages. "Typical" parameters which may be provided in Silicon Microstructure's data sheets and/or specifications can and do vary in different applications and actual performance may vary over time. All operating parameters, including "Typicals", must be validated for each customer application by customer's technical experts. Silicon Microstructures, Inc. does not convey any license under its patent rights nor the rights of others. Silicon Microstructures, Inc. makes no representation that the circuits are free of patent infringement. Silicon Microstructures, Inc. products are not designed, intended, or authorized for use as components in systems intended for surgical implant into the body, or other applications intended to support or sustain life, or for any other application in which the failure of the Silicon Microstructures, Inc. product could create a situation where personal injury or death may occur. Should Buyer purchase or use Silicon Microstructures, Inc. products for any such unintended or unauthorized application, Buyer shall indemnify and hold Silicon Microstructures, Inc. and its officers, employees, subsidiaries, affiliates, and distributors harmless against all claims, costs, damages, and expenses, and reasonable attorney fees arising out of, directly or indirectly, any claim of personal injury or death associated with such unintended or unauthorized use, even if such claim alleges that Silicon Microstructures, Inc. was negligent regarding the design or manufacture of the part.

Silicon Microstructures, Inc. warrants goods of its manufacture as being free of defective materials and faulty workmanship. Silicon Microstructures, Inc. standard product warranty applies unless agreed to otherwise by Silicon Microstructures, Inc. in writing; please refer to your order acknowledgement or contact Silicon Microstructures, Inc. directly for specific warranty details. If warranted goods are returned to Silicon Microstructures, Inc. during the period of coverage, Silicon Microstructures, Inc. will repair or replace, at its option, without charge those items it finds defective. The foregoing is buyer's sole remedy and is in lieu of all warranties, expressed or implied, including those of merchantability and fitness for a particular purpose. In no event shall Silicon Microstructures, Inc. be liable for consequential, special, or indirect damages.

While Silicon Microstructures, Inc. provides application assistance personally, through its literature and the Silicon Microstructures, Inc. website, it is up to the customer to determine the suitability of the product for its specific application. The information supplied by Silicon Microstructures, Inc. is believed to be accurate and reliable as of this printing. However, Silicon Microstructures, Inc. assumes no responsibility for its use. Silicon Microstructures, Inc. assumes no responsibility for any inaccuracies and/or errors in this publication and reserves the right to make changes without further notice to any products or specifications herein

Silicon Microstructures, Inc.TM and the Silicon Microstructures, Inc. logo are trademarks of Silicon Microstructures, Inc. All other service or product names are the property of their respective owners.

© Silicon Microstructures, Inc. 2001-2018. All rights reserved.